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a current blocking layer, formed on said second conductivity type cladding layer around said ridge portion, containing Al as a group III element in this order, wherein

an angle θ of inclination on a side surface of said ridge portion with respect to an upper surface of said substrate is at least 70° and not more than 117°,

a distance t between said emission layer and said current blocking layer satisfies a relation of t £ 0.275/(1 – (X2-X1)) micrometer assuming that X1 represents a composition ratio of Al in group III elements forming said second conductivity type cladding layer, X2 represents a composition ratio of Al in group III elements forming said current blocking layer, and a lower width W of said ridge portion is at least 2 μm and not more than 5 μm.

2. (Amended) A semiconductor laser device according to claim 1, wherein said first conductivity type cladding layer contains Al and Ga as group III elements, and X1 represents a composition ratio of Al in a sum of a contents of Al and Ga, and

said current blocking layer contains Al and Ga, and III elements, and X2 represents the composition ratio of Al in the sum of a contents of Al and Ga.

4. (Amended) The semiconductor laser device according to claim 1, wherein said distance t between said emission layer and said current blocking layer satisfies a relation of t £ 0.252/(1 - (X2-X1)) micrometer.

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5. (Amended) The semiconductor laser device according to claim 1, wherein said distance t between said emission layer and said current blocking layer is at least 0.15 μm.

(Cond.)

- 6. (Amended) The semiconductor laser device according to claim 1, wherein said distance t between said emission layer and said current blocking layer is at least $0.2~\mu m$.
- 7. (Amended) The semiconductor laser device according to claim 1, wherein an upper surface of said substrate is a {100} plane or inclined by several degrees, and said ridge portion extends in a <011> direction.